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ข้อความแห่งการริเริ่ม

- งานวิจัยนี้นำเสนอออกซิเคชันเชิงความร้อนที่ใช้ไมโครเวฟช่วยซึ่งเป็นเทคนิคที่ง่ายและ รวดเร็ว และนำเทคนิคไปใช้จนประสบความสำเร็จในการสังเคราะห์โครงสร้างนาโนของ ซิงก์ออกไซด์
- งานวิจัยนี้ประสบความสำเร็จในการสังเคราะห์ลักษณะเฉพาะพิเศษของโครงสร้างนาโน ซิงก์ออกไซด์ ที่มีรูปโครงสร้างแบบเตตระพอด ซึ่งขาเชื่อมกัน ดังนั้นจึงเรียกว่า โครงข่ายนา โนของเตตระพอดซิงก์ออกไซด์ และไม่เคยถูกค้นพบจากการสังเคราะห์ด้วยเทคนิคอื่นมา ก่อน
- งานวิจัยนี้เสนอตัวอย่างการประยุกต์ใช้ โครงข่ายนาโนของเตตระพอดซิงก์ออกไซด์ ที่ แสดงสมบัติ ทางไฟฟ้า, ทางแสง, และการตรวจวัดก๊าซ ที่ซึ่งแตกต่างจาก เตตระพอดเดี่ยว และผงของซิงก์ออกไซด์ ซึ่งนำไปสู่ศักยภาพใหม่ในการประยุกต์ใช้เป็นตัวตวจวัดยูวี และ ตัวตรวจวัดก๊าซ ซึ่งมีสมรรถนะดีขึ้น

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STATEMENT OF ORIGINALITY

- 1. The simple and fast technique of microwave-assisted thermal oxidation is introduced and successfully used to synthesizing ZnO nanostructures.
- The unique nanostructured ZnO morphology having tetrapod-like features with leg-to-leg connecting, so-called "inter-linked tetrapod network of ZnO" or ITN-ZnO is realized by using this technique and is rarely observed elsewhere with other growth techniques.
- 3. ITN-ZnO exhibits unexpectedly electrical, optical, and gas sensing properties that differ from tetrapod and powder leading to new potential applications. UV sensor and room temperature gas sensor with improved performance are demonstrated as an example.



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